Loresta-GX II MCP-T710

Accurate resistivity measurement using the reliable 4-pin probe method



Low resistivity meter, Measuring range $10^{-4} \sim 10^{7} \Omega$



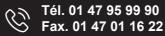


- **■** Expanded measuring range, $10^{-4} \sim 10^{7} \Omega$
- Silicon Mode for silicon wafer measurement
- One-touch automatic measurement by new functions, Auto-hold and Timer Mode
- Real-time output of measurement results



^{*}Probes for Loresta GX cannot be connected to Loresta GXII





Loresta-GX II

(MCP-T710)

- Accurate Low Resistivity Meter based on 4 Terminal 4 Pin Method
- \blacksquare One-touch measurement by dedicated probe on Ω . Ω/□. Ω·cm and S/cm
- Operation on Touch-Screen, RCF setting, Measurement, Data Save, Data Output and Data Management

Accurate and quick measurement of materials' resistivity

4 Terminal 4 Pin Method

- High accuracy with eliminating contact resistance between sample and probe and lead wire's resistance
- Dedicated probe with spring contact method keeps constant pin pitch, pressure and contact area on samples



Uses

■ Production engineering ■ Quality control ■ R & D

perpendicularly on samples.



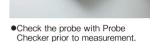
- Conductive paint, Conductive ink, Conductive paste, Resistive paste (carbon etc.), Conductive plastics, Conductive rubber. Silicon wafer
- Conductive films, Transparent conductive films, ITO Glass, Metal evaporated films, Sprayed metal layers, Sheet metals, Antistatic materials, Electromagnetic shield materials, Conductive fiber, Conductive ceramics, etc.
- Plating, Magnesium alloy, Surface treatment, etc.

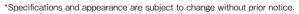
Features

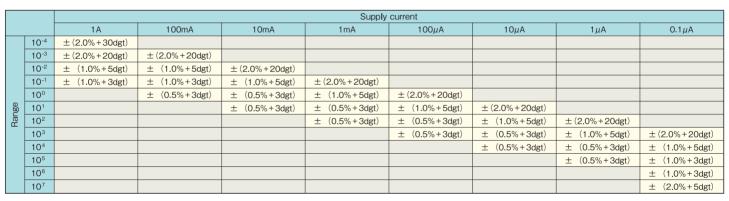
- **Expanded measuring range:** $0.001 \times 10^{-4} \sim 9.999 \times 10^{7} \Omega$
- One-touch operation: Automatic measurement with functional Auto-hold and Timer Mode
- Silicon Mode for silicon wafer measurement
- Low conductive materials are acceptable by Selectable Applied Current Function
- Current polarity reversing makes stable measurement
- Real-time output of measurement results to a PC (using data logger software sold separately)

Specifications

- Method: 4 Terminal 4 Pin Method
- Measurement mode : Auto-hold $\textbf{Mode: Measurement end by value's stability.} \quad \bullet \textbf{Dimensions, weight: W320} \times \textbf{D285} \times \textbf{H110mm,}$ Timer Mode: Measurement end by set time
- Display: 640x480dots, 7.5 inch full-color TFT-LCD touch screen
- Data output: USB flash drive, Serial (USB B)
- Power source: AC85~264V 47~63Hz, 40VA
- Lid opened H200mm, approx. 2.4kg
- Standard accessory: ASR probe RMH501 and Probe checker RMH304







Options

*Probes for Loresta GX cannot be connected to Loresta GXII



For non-uniform samples Pin pitch 5mm Pin point's diameter 2mm x 4pins Spring pressure 230g/pin



For soft surface samples Pin pitch 5mm Pin top hemisphere 2mm x 4pins Spring pressure 140g/pin



RMH504

*Company and product names contained herein are the trademarks or registared trademarks of the company concerned.

For small samples Pin pitch 1.5mm Pin points 0.26R x 4pins Spring pressure 95g/pin



For very small samples Pin pitch 1.5mm Pin points 0.26R x 4pins Pin arrangement Square Spring pressure 95g/pin



For very large samples Pin pitch 2.5mm Pin points 0.37R x 4pins Spring pressure 170g/pin



RMH507

For Silicon Wafer Pin pitch 1.0mm Pin points 0.04R x 4pins Spring pressure 250g/pin

Note:

Follow instructions in manuals to correctly install, connect and operate the instruments. Contents of catalogues are subject to change without prior notice when improvements are made in performance. The actual color of the goods may appear different from color printed. All screen images are simulated

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